

<b>Notice of References Cited</b>	Application/Control No. 10/539,960	Applicant(s)/Patent Under Reexamination DOMSCHKE ET AL.	
	Examiner Jennifer Y. Cho	Art Unit 1621	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0026077	02-2002	Collins et al.	562/608
*	B	US-6,172,242	01-2001	Eyal et al.	549/315
*	C	US-2003/0040086	02-2003	Dodge et al.	435/126
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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